

<b>Notice of References Cited</b>	Application/Control No. 10/700,096	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Michael Pervan	Art Unit 2629	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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**FOREIGN PATENT DOCUMENTS**

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	N	JP 05035202 A	02-1993	Japan	YAMAZAKI et al.	
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**NON-PATENT DOCUMENTS**

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